

OCT 12 2005

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Hopper, Peter

Attorney Docket No.: NSC1P282/P05730

Application No.: 10/665,897

Examiner: Rose, Kiesha

Filed: Sept. 18, 2003

Group: 2822

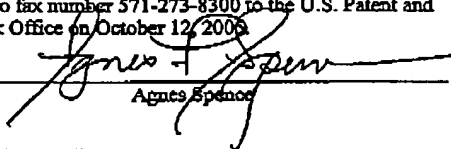
Title: APPARATUS AND METHOD FOR
FORMING HEAT SINKS ON SILICON ON
INSULATOR WAFERS

Confirmation No. 6996

CERTIFICATE OF FACSIMILE TRANSMISSION

I hereby certify that this correspondence is being transmitted by
facsimile to fax number 571-273-8300 to the U.S. Patent and
Trademark Office on October 12, 2005.

Signed: _____



Agnes Spence

AMENDMENT C

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In response to the Advisory Action dated August 24, 2005, please amend the
above-identified patent application as follows:

Amendments to the Claims are reflected in the listing of claims which begin
on page 2 of this paper.

Remarks/Arguments begin on page 4 of this paper.